



IFW

PATENT
8008-1050

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Hiroyoshi KUGE et al.

Conf. 3414

Application No. 10/786,552

Group 2825

Filed February 26, 2004

SEMICONDUCTOR INTEGRATED CIRCUIT
DEVICE AND DESIGN AUTOMATION
APPARATUS, METHOD AND PROGRAM

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In compliance with Rules 1.97 and 1.98, and in fulfillment of the duty of disclosure under Rule 1.56, the cited documents are made of record on the enclosed PTO Form-1449.

As the USPTO has waived the requirement under 37 CFR 1.98(a)(2)(i) for submitting a copy of each cited U.S. patent and patent publication for applications filed after June 30, 2003, copies of the cited U.S. references are not enclosed, as the present application is filed after June 30, 2003. Copies of the cited foreign patent documents and/or non-patent literature are enclosed.

A concise explanation of the relevance of these items is that these references were cited by the European Patent Office in the corresponding European Application Serial

Docket No. 8008-1050
Appln. No. 10/786,552

No. 04004080.0-2216. A copy of the European search report in which they were cited is attached hereto.

Respectfully submitted,

YOUNG & THOMPSON



Robert J. Patch, Reg. No. 17,355
745 South 23rd Street
Arlington, VA 22202
Telephone (703) 521-2297
Telefax (703) 685-0573
(703) 979-4709

RJP/fb

August 26, 2004

[illegible]